Search Notes



10/790,871

Examiner

James D. Stein

Applicant(s)/Patent under Reexamination

TATEIWA, AKIHIKO

Art Unit

2874

SEARCHED				
Class	Subclass	Date	Examiner	
385	27,31,39, 42	10/13/2005	JDS	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
385	27,31,39	10/13/2005	JDS	
385	42	10/13/2005	JDS	

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DATE	EXMR
10/13/2005	JDS
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